



Patent
Attorney Docket 4439

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Nobuhiro Hayashi, Takayoshi Hirono)
Isao Tada, Atsushi Nakatsuka)
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Application No.: 10/574,715)
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Filed: March 27, 2006)
)
For: Vacuum Evaporation Deposition Method)
of the Winding Type and Vacuum)
Evaporation Deposition Apparatus of the)
Same)
)
Pittsburgh, Pennsylvania

**AMENDMENT AFTER FINAL WITH REQUEST FOR EXTENSION
OF TIME AND CONTINUED EXAMINATION**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is filed in response to the final rejection dated October 9, 2008.

A request for a three month extension of time for response and a request for continued examination are attached, together with the required fees.

Kindly amend the claims as indicated hereinafter and consider the following remarks.